

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Thomas Teuschler et al.

Group Art Unit: 2813

Examiner: Tuan H. Nguyen

Serial No.: 10/762,111

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For: POLISHED SEMICONDUCTOR WAFER
AND PROCESS FOR PRODUCING IT

Attorney Docket No.: WSAG 0144 PUS

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated April 14, 2006, please amend the above-identified application as follows:

CERTIFICATE OF ELECTRONIC FILING

This paper, including all enclosures referred to herein, is being electronically filed with the U.S. Patent and Trademark Office EFS-Web System on: July 14, 2006.